

## Angular-tunable on-chip coding metasurface enabled by phase-change material with immersion liquid

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**Abstract:** Metasurfaces provide a potent platform for the dynamic manipulation of electromagnetic waves. Coupled with phase-change materials, they facilitate the creation of versatile metadevices, showcasing various tunable functions based on the transition between amorphous and crystalline states. However, the inherent limitation in tunable states imposes constraints on the multiplexing channels of metadevices. Here, this paper introduces a novel approach - a multi-functional metadevice achieved through the two-level control of the encoding phase-change metaatoms. Utilizing the phase-change material  $\text{Ge}_2\text{Sb}_2\text{Se}_4\text{Te}_1$  (GSST) and high refractive-index liquid diiodomethane ( $\text{CH}_2\text{I}_2$ ), this paper showcases precise control over electromagnetic wave manipulation. The GSST state governs the tunable function, switching it ON and OFF, while the presence of liquid in the hole dictates the deflection angle when the tunable function is active. Importantly, our tunable coding metasurface exhibits robust performance across a broad wavelength spectrum. The incorporation of high refractive-index liquid extends the regulatory dimension of the metadevice, enabling dynamic switching of encoding bit levels. This two-level tunable metadevice, rooted in phase-change materials, presents a promising avenue for the dynamic control of functions.

**Key words:** coding metasurface, tunable control, phase change material, electromagnetic wave manipulation

## 基于浸液相变材料的片上角度可调编码超表面

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**摘要:** 超表面为电磁波的动态调控提供了一个强大平台。超表面与相变材料的结合促进了多功能器件的产生, 其基于非晶态和晶态之间转换展示了多种可调的功能。然而, 可调状态的内在限制增加了对超器件多路复用的通道约束。介绍了一种通过对编码相变超单元进行二级调控实现多功能超器件的新方法, 利用相变材料  $\text{Ge}_2\text{Sb}_2\text{Se}_4\text{Te}_1$  (GSST) 和高折射率液体二碘甲烷( $\text{CH}_2\text{I}_2$ )实现了对电磁波调控的精确控制。设计的超表面

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由 GSST 的相态控制可调功能的开启和关闭,当可调功能开启时,微纳孔洞中液体的存在与否决定了偏折的角度。提出的可调编码超表面在宽波段展现了良好的鲁棒性。与高折射率液体结合拓展了超器件的调控维度,使器件能在不同比特编码间实现动态切换。基于相变材料的二级可调超器件为多功能的动态调控提供了一条可行的路径。

**关键词:** 编码超表面; 可调控制; 相变材料; 电磁波调控

**中图分类号:** O43

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## Introduction

Metasurfaces offer distinct advantages, such as compact dimension and low loss, making them widely employed in various applications including metalens, holograms, and optical vortex manipulation<sup>[1-4]</sup>. Traditionally, metasurface structures are fixed upon array configuration, limiting their adaptability. The growing demand for tunable metasurfaces has emerged with advancements in metasurface technology. The introduction of phase-change materials (PCMs), exemplified by the germanium-antimony-telluride (GST) family and vanadium dioxide ( $\text{VO}_2$ ), has facilitated the development of tunable metadevices<sup>[5-6]</sup>. PCMs undergo reversible transitions between amorphous and crystalline states, enabling the creation of multifunctional metalens, optical switches, and beam-steering devices<sup>[7-9]</sup>.

Notably, the integration of liquid crystals, diodes, and graphene in coding metasurfaces, where discrete phase shifts manipulate electromagnetic waves, has found extensive applications in tunable devices<sup>[10-13]</sup>. Moreover, coding metasurfaces utilizing PCMs have been widely adopted for dynamic applications. For example, Huang *et al.* designed a coding metasurface with switchable beam deflection and focusing based on GST<sup>[14]</sup>, while Lin *et al.* proposed a coding metasurface based on germanium telluride (GeTe) for dynamic modification of terahertz beams<sup>[15]</sup>. However, traditional PCM-based metasurfaces are constrained to only two tunable states, pre- and post-phase change. Recent attention has shifted towards miniaturized and highly integrated devices, particularly on-chip devices<sup>[16-18]</sup>. It offers advantages for the manipulation of in-plane electromagnetic wave propagation. Liquid-based tunable metamaterials, leveraging the ease of liquid addition and removal, have been developed with diverse functionalities.  $\text{CH}_2\text{I}_2$  with high refractive index has been utilized for aplanatic numerical aperture increasing lenses<sup>[19]</sup>. Switchable beam-steering has also been achieved through water immersion or drying<sup>[20]</sup>, and the filling height of water in integrated-resonant metaatoms is adjusted to tune the focal length of metalenses<sup>[21]</sup>. Metasurface with a strong polarization correlation shows different beam reflections in a liquid environment<sup>[22]</sup>. Water-immersion tuning scheme achieves the switch for both near- and far-field meta-display transformation<sup>[23]</sup>. Dynamic control of light fields is realized by flowing liquids with different refractive indices over nanostructures<sup>[24]</sup>. An environment-compliant tunable metaoptics is enabled by a liquid immersion tuning scheme<sup>[25]</sup>. Despite the versatility demonstrated in different states, the current approaches are limited in their maxi-

mal multiplexing channels.

In this work, we present a novel tunable coding metasurface designed for two-level control. Leveraging a combination of GSST and  $\text{CH}_2\text{I}_2$  liquid, our metasurface regulates in-plane electromagnetic waves across both single and broadband wavelengths. The tunable function is inactive when GSST is in the crystalline state, resulting in an indistinguishable deflection angle for etched holes with or without  $\text{CH}_2\text{I}_2$ . Conversely, when GSST transitions to the amorphous state, the tunable function activates, allowing the conversion of the coding metasurface from 3-bit to 4-bit, accompanied by a change in deflection angle when the etched hole is filled with  $\text{CH}_2\text{I}_2$ . We also discuss the impact of the refractive index of the liquid. This two-level control mechanism introduces a new avenue for designing on-chip dynamic tunable devices.

## 1 Design and theory

Fig. 1(a) illustrates the schematic of our tunable coding metasurface, designed as a beam deflection device operating at a wavelength of  $5.2\ \mu\text{m}$ . The tunable functionality, denoted as ON or OFF, is contingent upon the state of GSST, while the specific deflection angle is determined by the presence or absence of  $\text{CH}_2\text{I}_2$  liquid within the etched hole. The arrangement of the etched hole along the  $y$ -direction allows manipulation of the TE polarization (polarized along the  $y$ -direction) incident wave, propagating along the  $+x$ -direction. In the amorphous state of GSST, the deflection angle of the electromagnetic wave undergoes alteration upon filling or emptying the  $\text{CH}_2\text{I}_2$  liquid within the hole. Correspondingly, the phase distribution of the  $xy$ -plane is depicted in Fig. 1(b). This dynamic modulation of the deflection angle and phase distribution highlights the tunable nature of our coding metasurface, showcasing its ability to control electromagnetic waves based on the state of GSST and the presence of  $\text{CH}_2\text{I}_2$  liquid.

The metaatom's schematic diagram, as depicted in Fig. 2(a), comprises the etched hole, GSST, and  $\text{SiO}_2$  substrate. GSST is a kind of nonvolatile phase change materials, which phase state can maintain at room temperature. GSST has a large difference in the optical property between the crystalline and amorphous states<sup>[26]</sup>, making it a perfect candidate for the design of tunable metasurfaces. The GSST layer, with a thickness ( $H$ ) of  $2\ \mu\text{m}$ , plays a crucial role in the overall functionality. The dimensions of the etched hole, denoted as length ( $L$ ) and width ( $W$ ), are carefully tuned to achieve the desired deflection function. The periodicity of the metaatom, extending along the  $y$ -direction, is established at

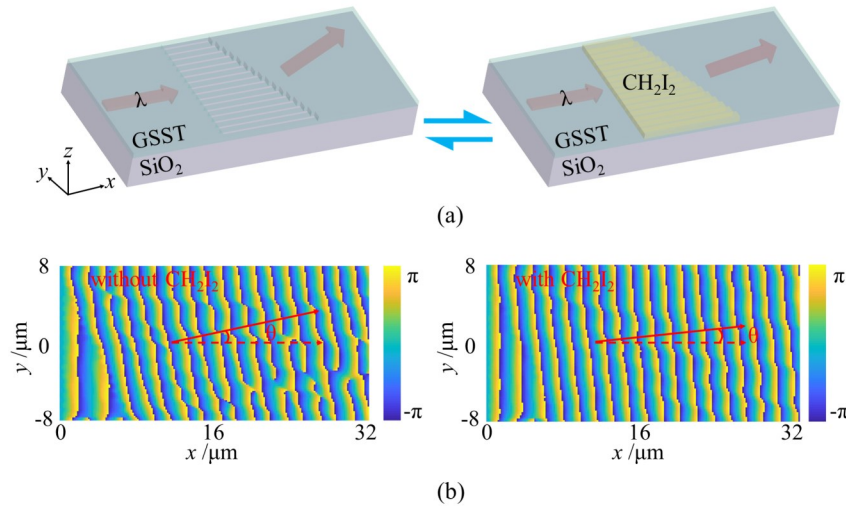


图1 设计的可调编码超表面的示意图:(a)可调编码超表面的结构功能展示(当相变材料GSST处于非晶态时,偏转角度随刻蚀孔中有无 $\text{CH}_2\text{I}_2$ 液体而变化);(b)刻蚀孔中有无 $\text{CH}_2\text{I}_2$ 液体的 $xy$ 平面的相位分布,其展现了超表面的可调性

Fig. 1 Schematic representation of the designed tunable coding metasurface: (a) illustration of the tunable coding metasurface's structural configuration (When the phase-change material, GSST, is in the amorphous state, the deflection angle varies in response to the presence or absence of  $\text{CH}_2\text{I}_2$  liquid in the etched hole); (b) phase distribution in the  $xy$ -plane without or with  $\text{CH}_2\text{I}_2$  liquid in the etched hole, showcasing the tunability of the metasurface

$P = 1 \mu\text{m}$ . It's necessary to have further consideration on the experimental feasibility. The GSST film can be deposited onto the substrate by thermal co-evaporation, and the desired film can be achieved by controlling the ratio of evaporation rates of two isolated targets of  $\text{Ge}_2\text{Sb}_2\text{Te}_5$  and  $\text{Ge}_2\text{Sb}_2\text{Se}_5$ . The GSST film can be etched via electron beam lithography and reactive ion etching. The GSST film can be changed to the crystalline state by hot-plate annealing at  $250^\circ\text{C}$  for 30 min<sup>[27]</sup>. The addition of  $\text{CH}_2\text{I}_2$  liquid can be by a pipettor and the removal of it can be by vaporization<sup>[28]</sup>. Therefore, the practical experimental is possible for this work. In terms of material properties, the refractive indices of GSST differ in its amorphous and crystalline states, measuring 3.19 and 4.65, respectively, at the operational wavelength of  $5.2 \mu\text{m}$ <sup>[26]</sup>. Additionally,  $\text{CH}_2\text{I}_2$  liquid, a key component, exhibits a refractive index of 1.691 at the specified wavelength ( $5.2 \mu\text{m}$ ) and temperature ( $20^\circ\text{C}$ )<sup>[29]</sup>. The high refractive index of  $\text{CH}_2\text{I}_2$  can provide a wide range of phase control, making it a good choice to replace low refractive index water or oil for the design of the tunable metasurface. To determine the refraction angle ( $\theta$ ), we employ the generalized Snell's law<sup>[30]</sup>, expressed as  $\theta = \sin^{-1}(\lambda/(n_i T))$ , where  $\lambda$  represents the designed wavelength,  $n_i$  is the effective refractive index of the refraction medium, and  $T$  signifies the super-period of the designed coding sequence. This formulation guides the modulation of the refraction angle based on the specified parameters, ensuring precise control over the metaatom's optical properties.

Figs. 2(b) to 2(f) collectively illustrate the four tunable states of the coding metasurface, offering insight into the phase shift and transmittance characteristics of

the metaatoms. In the amorphous state of GSST, the phase shift of the metaatom is approximately  $\pi/4$  and  $\pi/8$  for the etched hole without or with  $\text{CH}_2\text{I}_2$  liquid, respectively (Figs. 2(c) and 2(d)). According to the concept of coding metasurface,  $n$ -bit coding metasurfaces consist of  $2^n$  coding units with a phase difference of  $2\pi/2^n$ <sup>[10-12]</sup>. Due to the smaller discrete phase difference, higher bit coding provides more precise control of electromagnetic waves and the spurious interference will be effectively suppressed<sup>[31-32]</sup>. This distinction allows us to define the metaatoms as 3-bit and 4-bit coding configurations, respectively. Conversely, in the crystalline state of GSST, the phase shift remains approximately  $\pi/4$  for both configurations, regardless of the absence or presence of  $\text{CH}_2\text{I}_2$  (Figs. 2(e) and 2(f)). Consequently, in this crystalline state, the metaatoms are categorized as 3-bit coding. Notably, during the crystalline state of GSST, the tunable function of the coding metasurface is inactive, signifying that the tunable coding metasurface is in the OFF state.

## 2 Results and discussions

The validation of our designed tunable coding metasurface was conducted through full-wave simulations. In the amorphous state of GSST, when the tunable function is active, the simulated deflection angles for the etched hole without or with  $\text{CH}_2\text{I}_2$  liquid are  $12.1^\circ$  and  $5.9^\circ$ , respectively, as depicted in Fig. 3(a). The theoretically calculated deflection angles closely match at  $12.4^\circ$  and  $6.2^\circ$ , respectively. This alignment highlights the dynamic changes in the deflection angle corresponding to the presence or absence of  $\text{CH}_2\text{I}_2$  in the etched hole. Upon conversion of GSST into the crystalline state, the simulat-

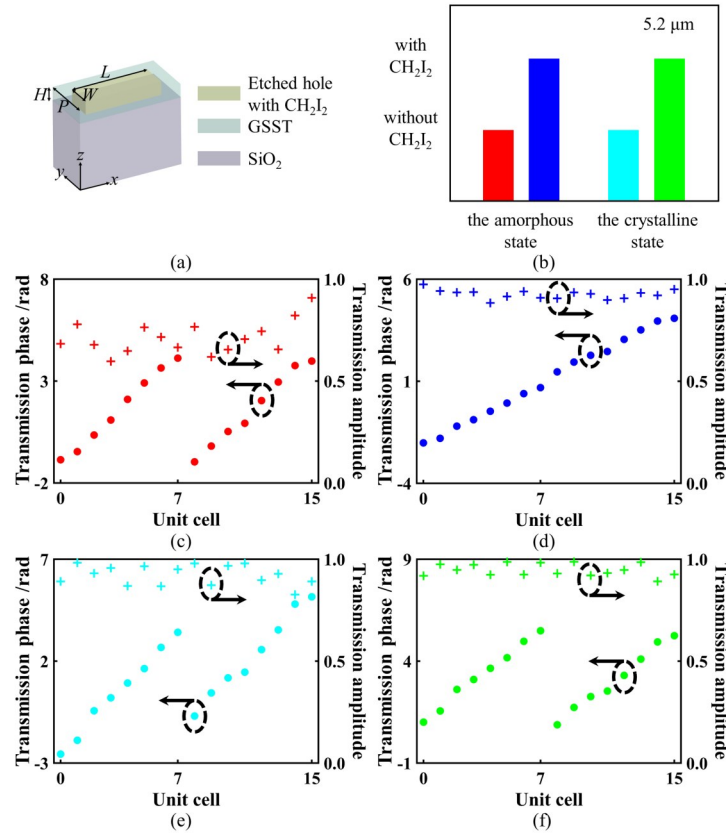


图2 超单元结构及其在不同相变状态下的可调特性:(a)超单元示意图,参数分别为 $H=2\ \mu\text{m}$ ,  $P=1\ \mu\text{m}$ ,  $W$ 从0变化到 $1\ \mu\text{m}$ ,  $L$ 从0变化到 $10\ \mu\text{m}$ ; (b)可调编码超表面的四个状态;非晶态GSST的编码超单元在刻蚀孔中(c)没有或者(d)有 $\text{CH}_2\text{I}_2$ 液体的透射系数和相移;晶态GSST的编码超单元在刻蚀孔中没有(e)或者有(f) $\text{CH}_2\text{I}_2$ 液体的透射系数和相移,以上说明了编码超单元在不同相变状态时的可调特性

Fig. 2 Metaatom configuration and its tunable characteristics across different phase-change states: (a) schematic illustration of the metaatom with parameters  $H = 2\ \mu\text{m}$ ,  $P = 1\ \mu\text{m}$ ,  $W$  ranging from 0 to  $1\ \mu\text{m}$ , and  $L$  from 0 to  $10\ \mu\text{m}$ ; (b) four states of the tunable coding metasurface; transmittance and phase shift of amorphous state GSST coding metaatoms when the etched hole is without (c) or with (d)  $\text{CH}_2\text{I}_2$  liquid; transmittance and phase shift of crystalline state GSST coding metaatoms when the etched hole is without (e) or with (f)  $\text{CH}_2\text{I}_2$  liquid. This highlights the tunable properties of the coding metaatoms in response to different phase-change conditions

ed deflection angles for the etched hole without or with  $\text{CH}_2\text{I}_2$  liquid are  $8.8^\circ$  and  $8.0^\circ$ , as illustrated in Fig. 3 (b). The theoretically calculated deflection angles for both cases are consistent at  $8.3^\circ$ . Remarkably, the presence of  $\text{CH}_2\text{I}_2$  has minimal impact on the deflection angle in this crystalline state. The phase distribution in the  $xy$ -plane for the four different states is presented in Figs. 3 (c)~(f). It is evident that the isophase of the wavefront propagating in-plane inclines to varying degrees in each state, resulting in distinct deflection angles in the far field. This observation reinforces the tunable nature of the coding metasurface, demonstrating its ability to dynamically control the direction of electromagnetic waves based on the state of GSST and the presence of  $\text{CH}_2\text{I}_2$ .

The potential influence of evaporation-induced fluctuations in the refractive index of  $\text{CH}_2\text{I}_2$  liquid on deflection is investigated by simulating four different refractive indices in both amorphous and crystalline states of GSST. The results, presented in Figs. 4 (a~d) and 4

(e~h), demonstrate the robustness of the coding metasurface in maintaining a consistent deflection effect within a certain range of liquid refractive indices. For the amorphous state of GSST, as the refractive index of the liquid varies between 1.4, 1.6, 1.9, and 2.0, the simulated deflection angles are  $6.8^\circ$ ,  $6.4^\circ$ ,  $5.5^\circ$ , and  $4.7^\circ$ , respectively (Figs. 4 (a~d)). Similarly, in the crystalline state of GSST, the simulated deflection angles for the same range of liquid refractive indices are  $8.4^\circ$ ,  $8.4^\circ$ ,  $7.6^\circ$ , and  $6.4^\circ$ , as shown in Figs. 4 (e~h). Notably, the coding metasurface exhibits a consistent and reliable deflection effect across different liquid refractive indices in both amorphous and crystalline states. Furthermore, the deflection angle decreases with an increase in the liquid refractive index, indicating the sensitivity of the deflection effect to variations in the refractive index of  $\text{CH}_2\text{I}_2$  liquid within the specified range.

In addition, we delved into the operational bandwidth of the proposed tunable coding metasurface. When



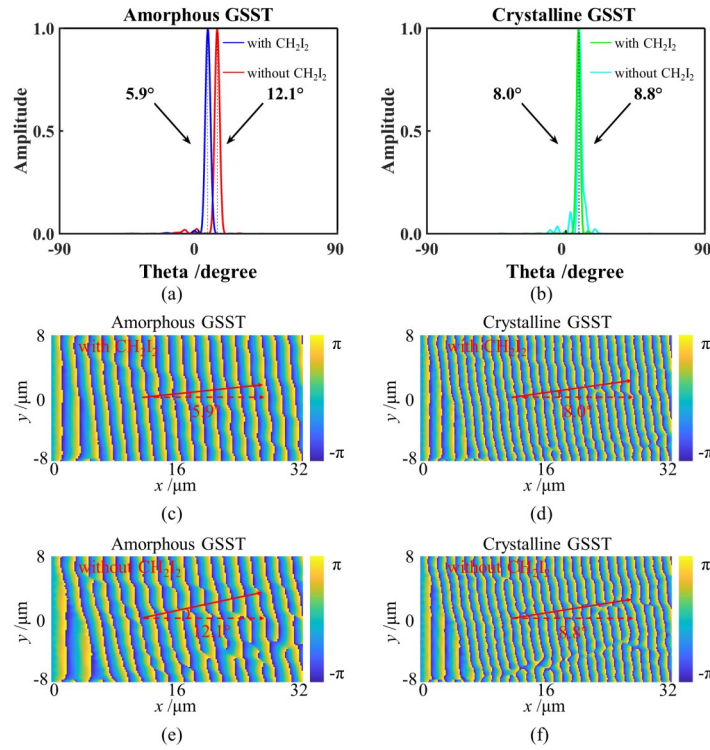


图3 可调编码超表面的偏折功能:(a)当GSST处于非晶态、波长为 $5.2\text{ }\mu\text{m}$ 时,刻蚀孔中有(蓝色线)或者没有(红色线) $\text{CH}_2\text{I}_2$ 液体的模拟远场散射图;作为对照,晶态GSST的散射图展示在(b)中;非晶态GSST刻蚀孔中有(c)或者没有(e) $\text{CH}_2\text{I}_2$ 液体在 $xy$ 平面的相位分布;晶态GSST刻蚀孔中有(d)或者没有(f) $\text{CH}_2\text{I}_2$ 液体在 $xy$ 平面的相位分布。这些结果说明了可调编码超表面在不同条件下的偏转特性

Fig. 3 Deflection function of the tunable coding metasurface: (a) simulated far-field scattering pattern of the etched hole with (blue line) or without (red line)  $\text{CH}_2\text{I}_2$  liquid at a wavelength of  $5.2\text{ }\mu\text{m}$  when GSST is in the amorphous state; For comparison, the scattering pattern of GSST in the crystalline state is also presented in (b); Phase distribution in the  $xy$ -plane with the etched hole containing (c) or lacking (e)  $\text{CH}_2\text{I}_2$  liquid in the amorphous state of GSST. Phase distribution in the  $xy$ -plane with the etched hole containing (d) or lacking (f)  $\text{CH}_2\text{I}_2$  liquid in the crystalline state of GSST. These results illustrate the deflection characteristics of the tunable coding metasurface under different conditions

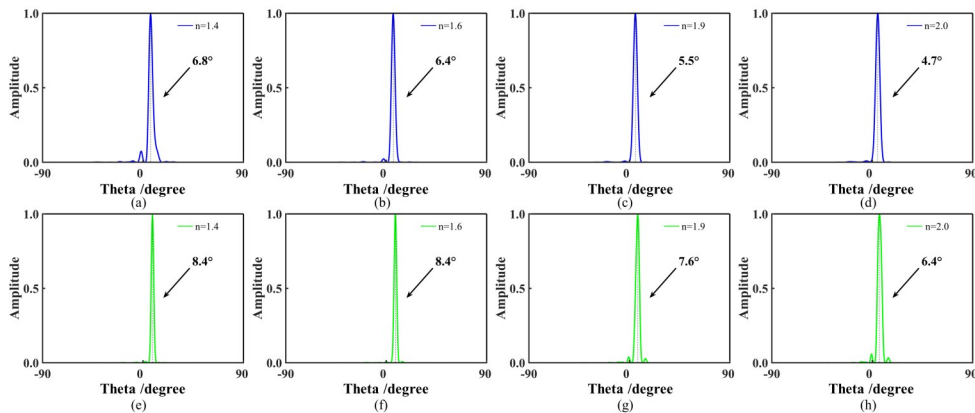


图4  $\text{CH}_2\text{I}_2$ 液体折射率的变化。非晶态GSST(a~d)和晶态GSST(e~h)在液体折射率分别为:1.4, 1.6, 1.9, 2.0时的模拟远场散射图。这些结果证明了 $\text{CH}_2\text{I}_2$ 液体折射率的变化对GSST非晶态和晶态散射角度的影响

Fig. 4 Refractive index changes of  $\text{CH}_2\text{I}_2$  liquid. Simulated far-field scattering patterns of amorphous state GSST (a~d) and crystalline state GSST (e~h) at refractive indices of the liquid: 1.4, 1.6, 1.9, and 2.0, respectively. These results demonstrate the influence of varying refractive indices of  $\text{CH}_2\text{I}_2$  liquid on the scattering patterns in both amorphous and crystalline states of GSST

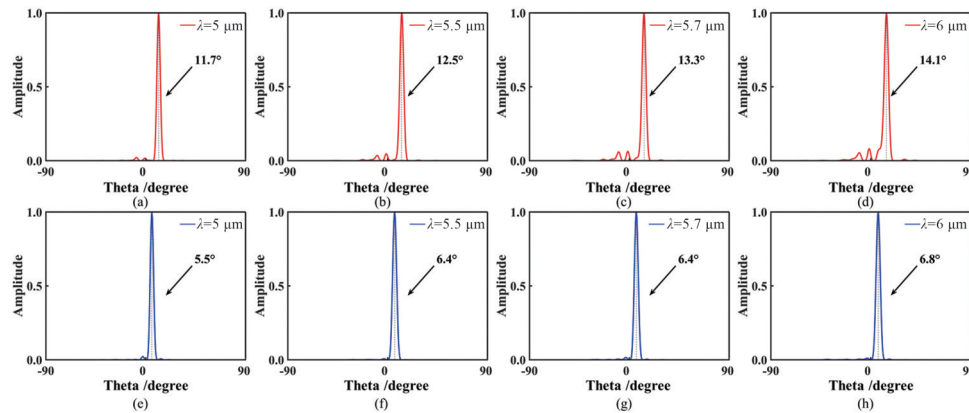


图5 宽带可调编码超表面。非晶态GSST刻蚀孔中没有液体(a~d)或有液体(e~h)的模拟远场散射图。波长分别为 $5\ \mu\text{m}$ ,  $5.5\ \mu\text{m}$ ,  $5.7\ \mu\text{m}$ ,  $6\ \mu\text{m}$ 。这些模拟结果显示了编码超表面的宽带可调性,展示了不同波长下的散射角度

Fig. 5 Broadband tunable coding metasurface. Simulated far-field scattering patterns of the etched hole without liquid (a~d) or with liquid (e~h) in the amorphous state of GSST. Wavelengths considered are  $5\ \mu\text{m}$ ,  $5.5\ \mu\text{m}$ ,  $5.7\ \mu\text{m}$ , and  $6\ \mu\text{m}$ , respectively. These simulations showcase the broadband tunability of the coding metasurface, highlighting the scattering patterns at different wavelengths

the device operates in the amorphous state of GSST, we found that the working wavelength of the metasurface can be expanded to a broadband range from  $5$  to  $6\ \mu\text{m}$ . The deflection angles of the etched hole without or with liquid at wavelengths of  $5\ \mu\text{m}$ ,  $5.5\ \mu\text{m}$ ,  $5.7\ \mu\text{m}$ , and  $6\ \mu\text{m}$  are illustrated in Fig. 5. At these specified wavelengths, the simulated deflection angle varies from  $11.7^\circ$  to  $14.1^\circ$  when the etched hole is without liquid, and from  $5.5^\circ$  to  $6.8^\circ$  when the etched hole is filled with liquid. According to the generalized Snell's law, the deflection angle is positive correlation with the working wavelength. Hence, the deflection angle is corresponding increases with the increase of working wavelength. This indicates that the deflection function remains valid across a broadband spectrum. The on-chip photonic device we designed exhibits robust performance, showcasing its suitability for applications requiring reliable and tunable deflection within a broad range of wavelengths.

### 3 Conclusions

In conclusion, our study successfully achieved two-level control of the coding metasurface, demonstrating versatility in both single and broadband wavelength applications. The tunable function of the on-chip device transitions from OFF to ON when GSST converts from the crystalline to the amorphous state. Under the OFF state, the deflection angle remains consistent whether the etched hole is without or with liquid. Conversely, under the ON state, the deflection angle is switchable based on the presence or absence of liquid in the etched hole. Notably, the deflection effect is robust and can be maintained regardless of changes in refractive index of liquid or operating wavelength, emphasizing the resilience of our on-chip photoelectric devices. Our findings open avenues for dynamic manipulation in on-chip devices, holding potential implications for the advancement of optical computational circuits, on-chip spectrometers, detectors, and other related technologies.

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